

JCSBY

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10029170	12/28/2001	438	706	1765	Chen K

**APPLICANTS: Ikegami Naokatsu;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A DIV OF 09/519,575 03/06/2000 PAT 6,355,572

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 245656/99 08/31/1999

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

OKI.153D

TITLE : Method of dry etching organic SOG film

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED

CLAIMS ALLOWED

Assistant Examiner

Total Claims

Print Claim for
O.G.

ISSUE FEE

Amount Due

Date Paid

DRAWING

Sheeto Drawg.

Fig. Drawg.

Print Fig.

Primary Examiner

PREPARED FOR ISSUE

Application Examiner



TERMINAL

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☒ CD-ROM

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